



#### **Features**

- 10 k0e (1 T) horizontal field superconducting magnet
- High stability operation from 2 K to 400 K
- Active cryogenic control of the cold head, magnet stage, and radiation shield
- Reduces potential for sample condensation by allowing sample to remain at room temperature while the system cools to 2 K
- Measurements from DC to 67 GHz
- Accommodates up to 25 mm (1 in) diameter wafers
- Configurable with up to four micro-manipulated probe arms
- Probe arms with 3-axis adjustments and ±5° theta planarization
- Cables, shields, and guards minimize electrical noise and thermal radiation losses
- High resolution optical system
- Non-magnetic vibration isolation table
- Options and accessories for customization to specific research needs

# Model HFTTP4 Probe Station

## Introduction

The Model HFTTP4 is a versatile cryogenic micromanipulated probe station used for non-destructive magnetic testing of devices on full and partial wafers up to 25 mm (1 in) in diameter. The HFTTP4 is a platform for measurement of magneto-transport, electrical, electro-optical, parametric, high Z, DC, RF, and microwave properties of materials and test devices. Nanoscale electronics, quantum wires and dots, semiconductors, superconductors, and spintronic devices are typical materials measured in a HFTTP4. A wide selection of probes, cables, sample holders, and options makes it possible to configure the HFTTP4 to meet your specific measurement applications.

Mounted on a non-magnetic vibration isolation table, the HFTTP4 is equipped with a 10 kOe (1 T) horizontal split-pair superconducting magnet. The HFTTP4 operates over a temperature range of 4.2 K to 400 K. With options, the base temperature can be extended down to 2 K. The probe station provides efficient temperature operation and control with a continuous refrigeration system using either helium or nitrogen. Vapor-cooled shielding optimizes efficiency and intercepts blackbody radiation before it reaches the sample. A wire wound control heater on the cold head minimizes temperature gradients across the sample and, along with the magnet stage and radiation shield heaters, provides the probe station with fast thermal response.

The HFTTP4 is user configured with up to four ultrastable micro-manipulated stages, each providing precise 3-axis control of the probe position to accurately land the probe tip on device features. Proprietary probe tips in a variety of sizes and materials minimize thermal mass and optimize electrical contacts to the device under test.

For increased versatility, HFTTP4 options include a 2 K base temperature stage, LN<sub>2</sub> Dewar kit, higher magnification monoscopes, vacuum turbo pumping system, and fiber optic probe arm modification.

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# **Applications**

- Magneto-transport measurements
- Electrical and electro-optical measurements over a wide temperature range
- RF and microwave
- Parametric testing
- Shielded/guarded/low noise characterization
- High Z
- Non-destructive, full wafer testing

## **Materials**

- Nanoscale electronics (carbon nanotube transistors, single electron transistors, molecular electronics, nanowires, etc.)
- Quantum wires and dots, quantum tunneling
- Single electron tunneling (Coulomb blockade)
- Superconductors
- Spintronic devices
- Basic semiconductor devices including organics, LEDs, and dilute magnetic semiconductors

# **Specifications**

## Magnetic Field

Maximum field 10 k0e (1 T)

## **Temperature**

Operating temperature range—all probe types	2 K to 400 K
Temperature control (heater)	
Cold head stage	50 W
Magnet stage	100 W
Two radiation shields	100 W and 50 W
Probe arm	Measurement only

## **Probe Arm Adjustments**

51 mm (2 in)	
25 mm (1 in)	
18 mm (0.7 in)	
20 µm	
10 μm	
±5°	

<sup>\*</sup>Included with microwave probes



**Frequency Range** 

ZN50 DC/RF probe frequency range	
Tungsten with cryogenic coax cable	0 to 50 MHz*
Tungsten with semirigid coax cable	0 to 1 GHz* <sup>†</sup>
Paliney 7 with cryogenic coax cable	0 to 50 MHz*
Paliney 7 with semirigid coax cable	0 to 1 GHz* <sup>†</sup>
BeCu with cryogenic coax cable	0 to 50 MHz*
BeCu with semirigid coax cable	0 to 1 GHz* <sup>†</sup>
GSG microwave probe frequency range	
Low frequency with K connector	0 to 40 GHz*
Mid frequency with 2.4 mm connector	0 to 50 GHz*
High Frequency with 1.8 mm connector	0 to 67 GHz*

# **Optical**

Optical viewport—located on top lids	Ø54 mm (2.1 in) outer window and Ø51 mm (2 in) inner window		
Outer, clear fused quartz	99% IR transmittance		
Inner	IR absorbing with narrow band visible light transmittance		
Optical resolution—monoscope			
7:1 zoom	9 μm		
12.5:1 zoom	5 μm*		
16:1 zoom	4 μm*		

<sup>\*</sup>Selectable equipment

# Sample Holder (Chuck)

Maximum sample size—overall	Up to Ø25 mm (1 in)
SH-1.00-G, Grounded chuck	Up to Ø25 mm (1 in) and 400 K
SH-1.00-I, Isolated chuck	Up to Ø25 mm (1 in) and 400 K*
SH-1.00-C, Coaxial chuck	Up to Ø25 mm (1 in) and 400 K*
SH-1.00-T, Triaxial chuck	Up to Ø25 mm (1 in) and 400 K*

<sup>\*</sup>Selectable equipment

<sup>\*</sup>Selectable equipment

† S21 > -10 dB up to 1 GHz, except for a (-40 dB) spike between 400 MHz and 800 MHz depending on probe model and placement; S11 < -3 dB up to 1 GHz



# **Standard Equipment**

Superconducting magnet	10 k0e (1 T), horizontal field, split pair	
Superconducting magnet power supply	Lake Shore Model 625	
Output type	Bipolar, 4-quadrant, DC current source	
Current	±60 A	
Voltage	±5 V	
Open cycle multi-stage refrigerator	4.2 K to 400 K	
Cold head stage temperature sensor	Lake Shore Model CX-1030-SD-HT-4M calibrated Cernox™ RTD	
Cold head stage heater	50 W	
Magnet stage temperature sensor	Lake Shore Model CX-1030-SD-HT-4M calibrated Cernox™ RTD	
Magnet stage heater	100 W	
Cooled radiation shield and cooled IR-absorbing window a	above the sample	
Two radiation shield temperature sensors	Lake Shore Model DT-670C-CU silicon diode	
Two radiation shield heaters	100 W and 50 W	
Removable top lid with viewport	Ø51 mm (2 in) window	
Temperature controllers	One Lake Shore Model 340 with 3462 expansion card, one Model 332S, and one Model 142 200 W (2 channels, 100 W each) power supply (independent regulation of cold head stage, magnet stage, radiation shield, and probe arm temperature monitoring)	
Vacuum chamber		
Diameter	25.4 cm (10 in)	
Removable top lid with clear fused quartz viewport	Ø54 mm (2.1 in) window	
Probe ports	4 equally spaced surround the sample thermal radiation shield	
Machined aluminum base plate	53.3 cm <sup>2</sup> (21 in <sup>2</sup> )	
Vibration isolation table	Low vibration, non-magnetic stand, PVC construction with sand weighted legs and brass fittings	
Four XYZ precision micro-manipulated probing stages		
Probe arms, thermal radiation shields, stainless steel wel	ded bellows, and feedthrough ports	
One probe mount includes a platinum temperature sensor	r installed and wired to a 6-pin feedthrough	
Grounded sample holder	SH-1.00-G, accommodates up to a $\emptyset$ 25 mm (1 in) sample with a $\emptyset$ 25 mm (1 in) probe area	
Optics		
Zoom 70 monoscope	7:1 zoom with 9 μm resolution	
Color CCD camera		
Swing arm	Optics can be manipulated to view any part of the sample or wafer, and	
	can be retracted and swung away to allow access to the top of the	
Video monitor	vacuum chamber for sample exchange	
Video monitor	High resolution, 17-inch  Coaxial via fiber optic or ring light from an adjustable light source and	
Sample illumination	power supply (must specify sample illumination at time of order)  NOTE: Coaxial illumination is recommended for highly reflective materials	
High efficiency helium transfer line with foot valve for p		
Basic tools, spares, and cleaning kit		
busic toots, spares, and cleaning kit		



# Probes, Probe Tips, and Cables — Required User Configurable Equipment

## **ZN50 DC/RF PROBES**

- Ideal for: DC biasing, low/high frequency measurements, low noise shielded, and low-leakage guarded measurement
- ZN50 probe base incorporates a pair of copper braids that connect to the sample stage to dynamically cool/heat the probe to the sample temperature
- SMA connector mounted directly to a replaceable alumina ceramic blade with a 50  $\Omega$  stripline routed to the probe contact

Part number (probe body)	Description
ZN50-26U	50 $\Omega$ stripline probe body mount (each probe body mount requires a ceramic blade—selectable below)

We understand that today's researcher requires flexibility. Our wide selection of probes, cables, sample holders, and options make it possible to configure a probe station to meet your specific measurement applications.

Part number (ceramic blade)	Tip material	Maximum frequency (GHz)	Tip radius (μm)
ZN50R-03-W			3
ZN50R-10-W	Tungsten		10
ZN50R-25-W			25
ZN50R-03-P7			3
ZN50R-10-P7	Paliney 7		10
ZN50R-25-P7		1*	25
ZN50R-03-BeCu			3
ZN50R-10-BeCu	D. C.		10
ZN50R-25-BeCu	BeCu		25
ZN50R-100-BeCu			100
ZN50R-200-BeCu			200

<sup>\*</sup>Maximum frequency 50 MHz with Z50-CU-SS-3650-G or Z50-CU-SS-3650-T cable; maximum frequency 1 GHz with K-085-K cable

## **ZN50 DC/RF CABLES**

Part number	Cable type	Connector type	Feedthrough type	Measurement configuration	Maximum frequency	Maximum temperature
Z50-CU-SS-3650-G	Ultra-miniature cryogenic coax	SMA	BNC	Shielded	50 MHz	400 K
Z50-CU-SS-3650-T	Ultra-miniature cryogenic coax	SMA	2-lug triax	Low leakage	50 MHz	400 K
K-085-K-09	Stainless semirigid microwave coax	К	Loss-less compression seal	High frequency	1 GHz*	400 K

<sup>\*</sup> S21 > -10 dB up to 1 GHz, except for a (-40 dB) spike between 400 MHz and 800 MHz depending on probe model and placement; S11 < -3 dB up to 1 GHz



## **GSG MICROWAVE PROBES**

- Coplanar waveguide probe with ground-signal-ground (GSG) contact geometry
- User-specified pitch (spacing)
- Optimized low thermal conductivity coax leading to low thermal conductivity tips
- Include a copper braid assembly to cool the probe to near sample temperature
- Limited to 400 K
- Separate theta planarization module with ±5° rotation mechanism is also provided

Part number	Connector type	Maximum frequency (GHz)	Pitch (µm)
GSG-050-40A-26U-DNM			50
GSG-100-40A-26U-DNM			100
GSG-150-40A-26U-DNM	K	40	150
GSG-200-40A-26U-DNM			200
GSG-250-40A-26U-DNM			250
GSG-050-50A-26U-DNM			50
GSG-100-50A-26U-DNM		50	100
GSG-150-50A-26U-DNM	2.4 mm		150
GSG-200-50A-26U-DNM			200
GSG-250-50A-26U-DNM			250
GSG-050-67A-26U-DNM			50
GSG-100-67A-26U-DNM			100
GSG-150-67A-26U-DNM	1.8 mm	67	150
GSG-200-67A-26U-DNM			200
GSG-250-67A-26U-DNM			250

## **GSG MICROWAVE CABLES**

- Loss-less compression seal
- Semirigid with stainless steel outer jacket, silver plated BeCu inner conductor, and Teflon® dielectric

Part number	Cable type	Feedthrough type	Maximum temperature	Connector type	Maximum frequency
K-085-K-09	Ctainlass samiriaid	Loss-less		K	40 GHz
2.4-085-2.4-09	Stainless semirigid	compression	400 K	2.4 mm	50 GHz
1.8-085-1.85-09	microwave coax	seal		1.8 mm	67 GHz



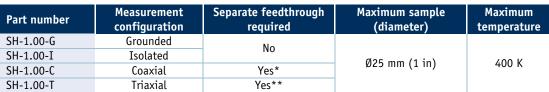
## **SAMPLE HOLDERS (CHUCKS)**

Typical sample holder configuration characterized by:

- Leakage resistance between
  - Top surface and quard
  - Guard and ground
- Capacitance between
  - Top surface and quard
  - Guard and ground



- Grounded sample holder—sample mount surface at system ground
- Isolated sample holder—backside contact not needed; sample mount surface is electrically non-conductive and isolated from ground
- Coaxial sample holder—backside contact can be made; sample mount surface is isolated from ground
- Triaxial sample holder—guarded backside contact can be made; sample mount surface has guarded isolation from ground



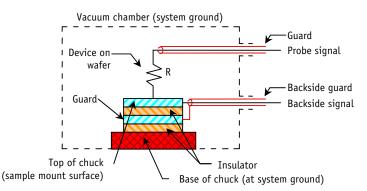
<sup>\*</sup>Coaxial sample holders require one FT-BNC or FT-TRIAX feedthrough as listed below

<sup>\*\*</sup>Triaxial sample holders require one FT-TRIAX feedthrough as listed below

Part number	Description
FT-BNC	Coaxial feedthrough and coax cable, installed and wired
FT-TRIAX	Triaxial feedthrough and coax cable, installed and wired

# **Equipment Options**

Part number	Description
PS-FOA	Fiber optic probe arm modification. Transmit or receive light or IR/UV radiation. Fiber optic terminated with SMA connector or compression feedthrough. (Fiber optic wire not included. Fiber optic and probe cannot be used simultaneously.)
PS-Z12.5	12.5:1 zoom monoscope upgrade for 5 μm resolution ΝΟΤΕ: upgrade is not field-installable
PS-Z16	16:1 zoom monoscope upgrade for 4 μm resolution NOTE: upgrade is not field-installable
PS-2K	2.0 K base temperature stage pumping option-includes system modifications, stainless steel flex hose for pump connection, and Varian DS402 rotary pump (12.3 CFM at 60 Hz with oil mist eliminator on output [with oil return], and inlet oil demister)
PS-DPC	Automatic Dewar (gas) pressure controller, regulates Dewar liquid flow
PS-V81TP	Turbo pumping system—includes Varian V-81 Turbo Pump cart with DS 102 backing pump, vacuum gauging for high vacuum and fore line, controller, and adaptors (specify 110 V/60 Hz or 220 V/50 Hz)
PS-V81DP	Turbo pumping system—includes Varian V-81 Turbo Pump cart with oil free backing pump, vacuum gauging for high vacuum and fore line, controller, and adaptors (specify 110 V/60 Hz or 220 V/50 Hz)
PS-LN2	Nitrogen Dewar with stainless fittings, gauges, and adaptors; allows LN <sub>2</sub> use with the LHe transfer line
PS-PLVI-40	Pump-line vibration isolator, with NW-40 fittings, 1 m stainless steel bellows, clamps, and rings (placed between pump cart and system); requires one bag of cement





# **Equipment Options, continued**

PS-TTVIS	Pneumatic tabletop vibration isolation system—compact pneumatic isolator with self-leveling (isolator resonance: vertical 3.2 Hz, horizontal 3.6 Hz; isolation efficiency at 10 Hz; vertical 90%, horizontal 96%; amplification at resonance: vertical 12 dB, horizontal 10 dB); requires 80 psi nitrogen or air
PS-OAC	Oil-less compressor for PS-TTVIS (only available in 110 V)
PA-SEN	Probe arm modification with platinum temperature sensor installed and wired to a 6-pin feedthrough
PA-HFTTP4	Probe arm and base for HFTTP4
MMS-HFTTP4	Micro-manipulated stage for HFTTP4
CS-5	Calibration substrate for GSG probes. Pad size: 50 µm²; calibration type: SOLT (short-open-load-through), LRL (line-reflective-line), LRM (line-reflective-match); pitch range: 75 to 250 µm
CS-15	Calibration substrate for GSG probes. Pad size: 25 µm²; calibration type: SOLT (short-open-load-through), LRL (line-reflective-line), LRM (line-reflective-match); pitch range: 40 to 150 µm

Lake Shore Cryotronics is a leading supplier of cryogenic, superconducting magnet-based, electromagnet-based, high vacuum, and load-lock probe stations. We offer a full line of standard probe stations to meet your research requirements.

## Our standard line of probe stations includes:

#### **Model TTP4**

- Up to four micro-manipulated probe stages
- Temperature range capabilities from 3.2 K to 475 K
- Up to 51 mm (2 in) diameter wafer capabilities

#### Model TTP4-1.5K

- Up to four micro-manipulated probe stages
- Standard temperature range from 1.5 K to 475 K
- Up to 25 mm (1 in) diameter wafer capabilities

### **Model TTP6**

- Up to six micro-manipulated probe stages
- Temperature range capabilities from 3.2 K to 475 K
- Up to 51 mm (2 in) diameter wafer capabilities

#### Model FWP6

- Up to six micro-manipulated probe stages
- Standard temperature range from 4.5 K to 475 K
- Up to 10.2 cm (4 in) diameter wafer capabilities

#### **Model LLTTP6**

- Load-lock for fast sample exchange at any temperature
- Up to six micro-manipulated probe stages
- Standard temperature range from 10 K to 400 K
- Up to 51 mm (2 in) diameter wafer capabilities; up to 12.7 mm (0.5 in) with load-lock assembly

#### Model HFTTP4

- 1 T horizontal field split pair superconducting magnet
- Up to four micro-manipulated probe stages
- Temperature range capabilities from 2 K to 400 K with field on or off
- Up to 25 mm (1 in) diameter wafer capabilities

#### Model VFTTP4

- 2.5 T vertical field solenoid superconducting magnet
- Up to four micro-manipulated probe stages
- Temperature range capabilities from 2 K to 400 K with field on or off
- Up to 51 mm (2 in) diameter wafer capabilities

#### **Model EMTTP4**

- 0.55 T horizontal (in-plane field) electromagnet
- Up to four micro-manipulated probe stages
- Standard temperature range from 5 K to 475 K
- Up to 25.4 mm (1 in) diameter wafer capabilities

#### **Model HVTTP6**

- High vacuum to 10<sup>-7</sup> torr
- Up to six micro-manipulated probe stages
- Temperature range capabilities from 2 K to 475 K
- Up to 51 mm (2 in) diameter wafer capabilities